

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukio SAKASHITA

Application No.: 10/542,956

Filed: April 24, 2006



Group Art Unit: 2813

Examiner: D. BLUM

Docket No.: 124796

For: THIN FILM CAPACITANCE ELEMENT
COMPOSITION, HIGH PERMITTIVITY
INSULATION FILM, THIN FILM
CAPACITANCE ELEMENT, THIN FILM
MULTILAYER CAPACITOR AND
PRODUCTION METHOD OF THIN FILM
CAPACITANCE ELEMENT

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

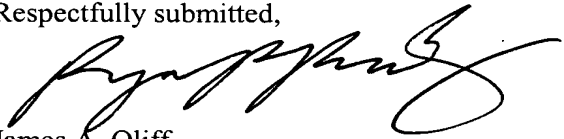
In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 226641 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Ryan R. Brady
Registration No. 62,746

JAO:RRB/mms

Date: February 22, 2010

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry of this filing;
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Deposit Account No. 15-0461